Proceedings of ASME 2023 International Design Engineering Technical Conferences and Computers and Information in Engineering Conference

(IDETC-CIE2023)

Volume 9

17th International Conference on Microand Nanosystems (MNS)

> August 20-23, 2023 Boston, Massachusetts

Conference Sponsors Design Engineering Division

Computers and Information in Engineering Division

THE AMERICAN SOCIETY OF MECHANICAL ENGINEERS

Two Park Avenue * New York, N.Y. 10016

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ISBN: 978-0-7918-8737-0

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